

ABSTRACT

A contactor apparatus having a first
contactor (2) and a second contactor (4) acquires an
5 electrical conduction to a plurality of
semiconductor devices formed on a semiconductor
wafer (6). The first contactor (2) has contacts
(2b) which are directly brought into contact with
power supply terminals (6a) of the semiconductor
10 devices. The second contactor (4) is movable
relative to the first contactor (2) and has contacts
(4a) which are brought into contact with signal
terminals (6b) of the semiconductor devices.
Thereby, the number of contacts to be formed on a
15 single contactor can be reduced and the number of
pattern wirings can also be reduced, which makes the
fabrication of the contactor easier.